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PATENT  
Docket No. J-3743

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Bryan L. Ackerman

Serial No.: 10/608,684

Filed: June 27, 2003

For: METHOD AND APPARATUS FOR  
APPLICATION OF A MATERIAL TO A  
SUBSTRATE

Group Art Unit: 1734

Examiner: Laura Estelle Edwards

Certificate of Mailing

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date:

) August 12, 2004

  
Erin J. Fox

Registration No. 52,261

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office action dated July 23, 2004, please consider the following remarks:

Remarks

Claims 1-17 are pending and at issue in the present application.

Applicant hereby elects for prosecution in the present application Group III comprising claims 11-15, which are directed to an apparatus for applying an adhesive to a substrate. Applicant further contends that claims 16 and 17 should be included in Group III because such claims are also directed to an apparatus for applying an adhesive to a substrate. Accordingly, applicant requests that claims 16 and 17 be retained and examined in the present application.